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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshimitsu HIRAI

Group Art Unit: 2822

Application No.: 10/803,027

Examiner: M. WILCZEWSKI

Filed: March 18, 2004

Docket No.: 119152

For: METHOD OF FORMING THIN-FILM PATTERN, METHOD OF MANUFACTURING  
DEVICE, ELECTROOPTICAL APPARATUS AND ELECTRONIC APPARATUS

**AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 27, 2006 Restriction Requirement, please consider the  
following:

**Amendments to the Claims** as reflected in the listing of claims;

**Remarks.**